

EFK



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2628  
Examiner: Antonio A. CASCHERA

In Re PATENT APPLICATION of:

Applicant: Hong-Long CHOU et al.

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Serial No.: 10/626,698

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Filing date: July 25, 2003

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AMENDMENT

For: A MULTILEVEL TEXTURE  
PROCESSING METHOD FOR  
MAPPING MULTIPLE IMAGES  
ONTO 3D MODELS

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Atty. ref.: TAIW 155

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April 10, 2007

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on January 10, 2007, please  
amend the above-identified application as follows:

FEE ENCLOSED: \$ 0.00  
Please charge any further fee to  
our Deposit Account No. 18-0002